

Electronic Acknowledgement Receipt

EFS ID:	2110040		
Application Number:	10812409		
International Application Number:			
Confirmation Number:	1261		
Title of Invention:	System and method for performing sputter etching using independent ion and electron sources and a substrate biased with an a-symmetric bi-polar DC pulse signal		
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Filer:	Daniel H. Golub		
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /zip	Pages (if appl.)				
1		Response20070822.pdf	116926 06fa098e338731d23e39f78d14990649 dc56026	yes	2				
Multipart Description/PDF files in .zip description									
Document Description		Start		End					
Amendment - After Non-Final Rejection		1		1					
Applicant Arguments/Remarks Made in an Amendment		2		2					
Warnings:									
Information:									
2	Terminal Disclaimer Filed	TerminalDisclaimer1.pdf	349288 e44ce438cd51ef8a1cd28210cc09f48 doc444	no	2				
Warnings:									
Information:									
3	Terminal Disclaimer Filed	TerminalDisclaimer2.pdf	349281 e711bd3785cf2bdff40f8a50549cd40f 2bb0b1	no	2				
Warnings:									
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Total Files Size (in bytes):				815495					
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